

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yan Borodovsky Art Unit: 1756
Serial No.: 10/693,373 Examiner: Daborah Chacko Davis
Filed: October 24, 2003 Assignee: Intel Corporation
Title: COMPOSITE OPTICAL LITHOGRAPHY METHOD FOR PATTERNING
 LINES OF UNEQUAL WIDTH

MAIL STOP AMENDMENT

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

In response to the Office action mailed July 19, 2006,
please reconsider this application in light of the following:

Amendments to the claims set forth in the **Listing of Claims**
beginning on page 2; and

Remarks beginning on page 6.